Possibility of high-Z plasma water window sources



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Summary

(a) Line spectrum

(b) UTA

wavelengths below the carbon K edge.

λ (nm)

λ (nm)

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We have demonstrated high-efficiency emission in the water window

spectral region based on laser-produced high-Z plasmas and have

proposed methods to increase it still further. Resonance emission from

multiply charged ions merges to produce intense UTA, extending to

Abstract

We demonstrate EUV and soft x-ray sources in the 2 to 7 nm spectral region related to the beyond EUV (BEUV) question at 6.x nm and a water window source based on laser-produced high-Z plasmas. Resonance emission from multiply charged ions merges to produce intense unresolved transition arrays (UTAs), extending below the carbon K edge (4.37 nm). We will discuss the progress and Z-scaling of UTA emission spectra to achieve lab-scale table-top, efficient, high-brightness high-Z plasma EUV-soft x-ray sources with the soft x-ray microscope for in vivo bio-imaging applications.

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Water Window

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Background



(A) Optical micrograph of a fossil diatom sample. The area scanned by the x-ray beam is marked by a black frame.
(B) Complex-valued ptychographic reconstruction of the object transmission function from the same diatom sample as

shown in subfigure A.

K. Giewekemeyer et al., Opt. Exp. 19, 1037 (2011).

Experimental results



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"Water window" sources: Selection based on the interplay of spectral properties and multilayer reflection bandwidth

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